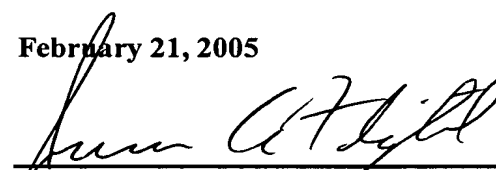




IFW

PATENT
Docket No. 20063/OG03-045

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s):)	I hereby certify that this paper and the
)	documents referred to as enclosed
KIM et al.)	therewith are being deposited with the
)	United States Postal Service as first
U.S. Serial No.: 10/747,599)	class mail, postage prepaid, in an
)	envelope addressed to Commissioner
For: "Methods for Fabricating)	for Patents, P.O. Box 1450,
Semiconductor Devices")	Alexandria, Virginia 22313-1450 on
)	this date:
Filed: December 29, 2003)	
)	February 21, 2005
Group Art Unit: 1765)	
)	
Examiner: Not Yet Assigned)	
)	
)	
)	James A. Flight
)	Attorney for Applicant(s)
)	Registration No. 37,622

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

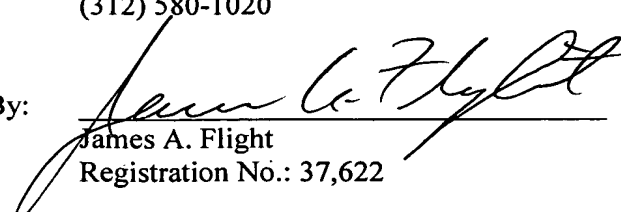
Kindly advise when an Office action can be expected in the above-referenced matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC
USPTO Customer Number 34431
20 North Wacker Drive
Suite 4220
Chicago, Illinois 60606
(312) 580-1020

February 21, 2005

By:


James A. Flight
Registration No.: 37,622